



AF/ 2851

PATENT
Customer No. 22,852
Attorney Docket No. 04788.0247

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yasuhiro OMURA

Application No.: 09/865,734

Filed: May 29, 2001

For: PROJECTION OPTICAL SYSTEM,
EXPOSURE APPARATUS
INCORPORATING THIS
PROJECTION OPTICAL SYSTEM,
AND MANUFACTURING METHOD
FOR MICRO DEVICES USING
THE EXPOSURE APPARATUS

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)
) Group Art Unit: 2851

)
) Examiner: Hung Nguyen
)

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a three-month extension of time to reply to the
Office Action of June 4, 2003. A fee of \$950.00 is enclosed.

Please grant any extensions of time required to enter this response and charge
any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

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Dated: December 4, 2003

By: *Doris J. Hines* Reg 24,014
for Doris J. Hines
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